

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. <b>243863US3DIV</b>		SERIAL NO. <b>New Application</b>	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT <b>Hitoshi SAKAMOTO, et al.</b>			
				FILING DATE <b>Herewith</b>		GROUP	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
<b>R R B</b>	<b>AA</b>	<b>6,440,494</b>	<b>08/02</b>	<b>Arena-Foster, Chantal</b>			
<b>R R B</b>	<b>AB</b>	<b>5,716,451</b>	<b>02/98</b>	<b>Hama et al.</b>			
<b>R R B</b>	<b>AC</b>	<b>5,292,370</b>	<b>03/94</b>	<b>Tsai et al.</b>			
<b>R R B</b>	<b>AD</b>	<b>5,980,687</b>	<b>11/99</b>	<b>Koshimizu, Chishio</b>			
	<b>AE</b>						
	<b>AF</b>						
	<b>AG</b>						
	<b>AH</b>						
	<b>AI</b>						
	<b>AJ</b>						
	<b>AK</b>						
	<b>AL</b>						
	<b>AM</b>						
	<b>AN</b>						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES                  NO		
<b>R R B</b>	<b>AO</b>	<b>EP 573348 A1</b>	<b>12/93</b>	<b>European Patent</b> <i>(abstract only)</i>			
	<b>AP</b>						
	<b>AQ</b>						
	<b>AR</b>						
	<b>AS</b>						
	<b>AT</b>						
	<b>AU</b>						
	<b>AV</b>						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	<b>AW</b>						
	<b>AX</b>						
	<b>AY</b>						
	<b>AZ</b>						<input type="checkbox"/> Additional References sheet(s) attached
Examiner <b>R Bueh</b>					Date Considered <b>12-2005</b>		
<small>*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

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<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
<b>RRB</b>	AA	4,626,448	12/02/86	A. K. HAYS			
<b>RRB</b>	AB	5,091,209	02/25/92	P. CLAVERIE, et al.			
<b>RRB</b>	AC	4,829,215	05/09/89	K. KIM, et al.			
<b>RRB</b>	AD	6,174,809	01/16/2001	Sang-bom KANG, et al.			
	AE						
	AF						
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	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	0 482 265	04/29/92	EUROPE (submitting corr. US 5,091,209 and JP 2856782 only)			
<b>RRB</b>	AP	2856782	05/30/91	JAPAN			X
<b>RRB</b>	AQ	05-198520	08/06/93	JAPAN (submitting English Abstract only)			
<b>RRB</b>	AR	5-85890	04/06/93	JAPAN (submitting English Abstract only)			
<b>RRB</b>	AS	61-86942	05/02/86	JAPAN (submitting corr. US 4,829,215 only)			
<b>RRB</b>	AT	11-238698	08/31/99	JAPAN (submitting English Abstract and corr. US 6,174,809 only)			
	AU						
	AV						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
<b>RRB</b>	AW	N. BOURHILA, et al., Microelectronic Engineering, vol. 33, pages 25-30, "COPPER LPCVD FOR ADVANCED TECHNOLOGY", 1997					
	AX						
	AY						
	AZ						
Examiner <b>R. Buhl</b>					Date Considered <b>12-2005</b>		
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